

WHAT IS CLAIMED IS:

1. An assay device washing module for washing an assay device located within an assay device well holder, the module comprising a wash fluid delivery probe and an aspirator probe mounted to a movable support, the aspirator probe being mounted at an angle to the vertical and the support being movable at substantially the same angle whereby when the aspirator probe is inserted into a well holder it is brought close to the side of the well holder.
2. A module according to claim 1, further comprising a probe wash region located beneath the wash location of the well holder, the support being movable, in the absence of a well holder, to bring the aspirator probe into the wash region.
3. A module according to claim 1, further comprising a probe wash fluid delivery system coupled with the probe wash region selectively to supply probe wash fluid to the probe wash region.
4. A module according to claim 1, further comprising a vacuum supply system coupled to the aspirator probe, the vacuum supply system including a vacuum vessel having a first port connected to a vacuum source, a second port connected to the aspirator probe and a third port connected to a drain via a drain pump.
5. A module according to claim 1, further comprising a vacuum supply system coupled to the aspirator probe, the vacuum supply system including a vacuum vessel having a first port connected to the vacuum source, a second port connected to the aspirator probe and a third port connected to a drain via a drain pump.